		449U.S. DEPARTN		AGENT. DO AFC-002/R APPLICAN	1	SERIAL NO. Not Yet Assigned				
LIST		PRIOR ART CITE Use several sheets i		CANT	Arrayed Fil		orporation	_		
					FILING DATE			GROUP		
	· · ·		VI O D 4 D		Filed Herev		Not Yet	Assigne	ea	
XAMINER	т-	DOCUMENT	DATE	ENT DO	NAME	CLASS	SUBCLASS	FILIN	G DATI	
INITIAL		NUMBER					JOBOLI IGO		IF PRIAT	
gh	A	3968564	Jul. 13, 1976	Springtho	oringthorpe. 438 27		27	Apr. 30, 1975		
91	В	4292512	Sep. 29, 1981	Miller et a	al.	250	250 205		Jun. 19, 1978	
The	С	4466696	Aug. 21, 1984	Carney.		385	49	Mar. 29	, 1982	
gh	D	4897711	Jan. 30, 1990	Blonder e	t al.	257	48	Mar. 30, 1988		
Sh	E	4934784	Jun. 19, 1990	Kapany et	al.	385 33		Mar. 20, 1989		
The	F	4945400	Jul. 31, 1990	Blonder e	Blonder et al. 257 116		116	Oct. 30, 1989		
Sh	G	5181224	Jan., 19 1993	Synder.		372	101	May 10, 1991		
The .	Н	5195150	Mar. 16, 1993	Stegmueller et al.		385	33	Jan. 27, 1992		
9/	I	5247597	Sep. 21, 1993	Blacha et al.		385	88	Jun. 15, 1992		
Sh	J	5259054	Nov. 2, 1993	Benzoni et al.		385	89	Jan. 10,	1992	
00	K	5337398	Aug. 9, 1994	Benzoni et al.		385	90	Nov. 30), 1992	
W	L	5345529	Sep. 6, 1994	Sizer, II et al.		385	147	Jul. 6, 1993		
The	M	5346583 .	Sep. 13, 1994	Basavanhally.		216	26	Sep. 2, 1993		
Th	N	5434939	Jul. 19, 1995	Matsuda.		385	88	Feb. 8, 1994		
o gr	o	5471552	Nov. 28, 1995	Wuu et al.		385	49	Feb. 22, 1995		
gr,	P	5501893	Mar. 26, 1996	Laermer et al.		428	161	Aug. 5, 1994		
W	Q	5742720	Apr. 21, 1998	Kobayashi et al.		385	89	Aug. 29, 1996		
1/2	R	5859940	Jan. 12, 1999	Takahashi et al.		385	34	Mar. 7, 1997		
1/2	s	6023546	Feb. 8, 2000	Tachigori.		385	49	Jul. 1, 1998		
y/r	T	6527455	Mar 4, 2003	Jian		385	88	Nov. 26, 2001		
V			FOREIGN I	PATENT	DOCUMEN	TS				
		DOCUMENT NUMBER	DATE	C	OUNTRY	CLASS	SUBCLASS	TRANS		
Th	U	6-138341	May. 20, 1994		Japan	++		YES	NO	
					- apuii					
EXAMINER Marie Marie Considered (2/23/04)							1 4 1	· · · <u>-</u> · · · · ·	I	
EXAMIN	ER:	Initial if reference consi ce and not considered.	dered, whether or n	ot citation i	s in conformanc	e with MPEP	509; Draw line	through c	itation	

FORM P	TO-14	49U.S. DEPARTMENT OF COMMERCE	AGENT. DOCKET NO.	SERIAL NO.						
			AFC-002/RE	Not Yet Assigned						
LIST	OF P	RIOR ART CITED BY APPLICANT	APPLICANT							
	(U	se several sheets if necessary)	Arrayed Fiberoptics Corporation							
			FILING DATE	GROUP						
			Herewith	Not Yet Assigned						
OTHER PRIOR ART (Including Author, Title, Date, Pertinent Pages, Etc.)										
Examiner	Cite									
Initials	No.	magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published								
The	V	CARSON et al., "Future Manufacturing Techniques for Stacked MCM Interconnections", Journal of Metal, Jun. 1994, pp. 51-55.								
The state of the s	W	DASCHNER et al., "Fabrication of Monolithic Diffractive Optical Elements by the Use of E-Beam Directed Write on an Analog Resist and a Single Chemically Assisted Ion-Beam-Etching Step", Applied Optics, vol. 34, No. 14, May 1995, pp. 2534-2539.								
Mr.	X	IGA, "Active Parallel Microoptics", SPIE vol. 1319 Optics in Complex Systems, 1990, pp. 486-490.								
The	Y	IGA et al., "Distributed-index Planar Microlens and Stacked Planar Optics: A Review of Progress", Applied Optics, vol. 25, No. 19 Oct. 1986, pp. 3388-3396.								
W.	Z	IGA, "Chapter 10: Stacked Planar Optics", Fundamentals of Microoptics, Academic Press, 1984, pp. 195-207 and pp 6-7.								
H	AA	IGA et al., "Stacked Planar Optics: An Application of the Planar Microlens", Applied Optics, vol. 21, No. 19, Oct. 1982, pp. 3456-3460.								
The second	AB	IGA, "Two-dimensional Arrayed Microoptics", TUB2, Invited Paper, CLEO, 1989, pp. 44-45.								
X	AC	KO et al., "Bonding Techniques for Microsensors", Micromachining and Micropackaging of Transducers, Elsevier Science Publisher, Amsterdam, 1986, pp. 41-61.								
The	AD	LEE et al., "Low Cost High Quality Fabrication Methods and CAD for Diffractive Optics and Computer Holograms Compatible with Micro-Electronics and Micro-Mechanics Fabrication", Diffractive Optics and Optical Microsystems, Plenum Press New York, 1997, pp. 133-138.								
W.	AE	MATSUDA et al., "A Surface-Emitting Laser Array with Backside Guiding Holes for Passive Alignment to Parallel Optical Fibers", IEEE Photonics Technology Letters, vol. 8, No. 4, Apr. 1996, pp. 494-496.								
Sh	AF	OIKAWA et al. "Optical Tap Array Using Distributed-Index Planar Microlens", Electronics Letters, vol. 18, No. 18, Apr. 15, 1982, pp. 316-317.								
Th	AG	REIMER et al., "Micro-Optic Fabrication Using One-Level Gray-Tone Lithography", SPIE, vol. 3008, 1997, pp. 279-288.								
H.	AH	STRZELECKA et al., "Monolithic Integration of Verical-Cavity Laser Diodes With Refractive GaAs Microlenses", Electronics Letters, vol. 31, No. 9, Apr. 1995, pp. 724-725.								
Jo	AI	Tai, "90% Coupling of Top Surface Emitting GaAs/AlGaAs Quantum Well Laser Output Into 8 Micron Diameter Core Silica Fibre", Electronics Letters, vol. 26, No. 19, Sep. 1990, pp. 1628-1629.								
The	AJ	WANG et al., "Robust Regression Applied to Optical-Fiber Dimensional Quality Control", Technometrics, vol. 39, No. 1, Feb. 1997, pp. 25-33.								
Th	AK	DOHLE et al., "Low Temperature Bonding of Epitaxial Lift Off Devices With AuSn", IEEE Transactions on Components, Packaging, and Manufacturing Technology, Part B, vol. 19, No. 3, Aug. 1996, pp. 575-579.								
EXAMI	li	m por	TE CONSIDERED, (2/23/04)							
		nitial if reference considered, whether or not citation e and not considered. Include copy of this form with								